surface, wherein the generation of pinholes is suppressed to meet a predetermined condition;

polishing the casting to reduce a roughness of said casting surface to  $form \ a \ polished \ surface \ with \ a \ roughness \ R_{max} \ not \ more \ than \ a \ predetermined \ value;$  painting the casting after being polished to form a first resin coating layer on said polished surface; and

plating said casting after being painted to form a layer of a metal or a metal compound through a dry-type plating on a surface of said first resin coating layer;

wherein said step of casting includes an auxiliary pressurizing step for applying, by a pressurizing pin, a pressurizing force to said molten metal of said lightmetal material filled in a die cavity, in addition to an application of said casting pressure, during a solidification process of said molten metal under said casting pressure.

- 2. (Once Amended) The method as described in claim 1, wherein the predetermined condition of the pinholes generated on said polished surface is that the number and a maximum opening dimension of the pinholes generated in a predetermined area of the polished surface is not more than a predetermined value.
- 3. (Once Amended) The method as described in claim 2, wherein the number of said pinholes is in the range of 1 to 15 per 100 cm<sup>2</sup> of said polished surface and said maximum opening dimension is not more than 2 mm.
- 4. (Once Amended) The method as described in claim 3, wherein that the number of said pinholes is in the range of 1 to 10 per 100 cm<sup>2</sup> of said polished surface,

said maximum opening dimension is not more than 2 mm and the number of the pinholes having the maximum opening dimension of 1.0 to 2.0 mm is one or zero.

- 5. (Once Amended) The method as described in claim 1, wherein roughness of said polished surface obtained by said polishing step is 6.3  $\mu$ m in  $R_{max}$ .
- 6. (Once Amended) The method as described in claim 1, wherein said first resin coating layer is not less than 10 μm and not more than 40 μm thick.
- 7. (Once Amended) The method, as described in claim 1, wherein a transparent second resin coating layer is formed on said metal or metal compound layer.
- 8. (Once Amended) The method as described in claim 7, wherein each of said first and second resin coating layers includes a primer coating layer.
- 9. (Once Amended) The method as described in claim 7, wherein said transparent second resin coating layer is not less than 20  $\mu$ m and not more than 50  $\mu$ m thick.
- 10. (Once Amended) The method as described in claim 1, wherein said polishing step is a barrel finishing process.
- 11. (Once Amended) The method as described in claim 1, wherein said plating step for forming a layer of a metal or a metal compound through said dry-type plating is a sputtering process.
  - 12. (deleted)
- 13. (Once Amended) The method as described in claim 1, wherein said casting of said light-metal material is an aluminum wheel.

